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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hidemasa KAI**

Group Art Unit: **1763**

Serial Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR  
STRUCTURE**

Attorney Docket Number: **030901**

Customer Number: **38834**

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Date: July 21, 2005

Sir:

This paper is submitted in response to the Official Action dated June 23, 2005.

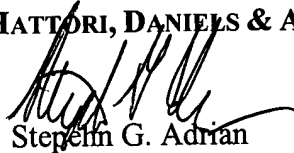
In the Action, restriction is required between Group I, Claims 1-2; Group II, Claims 3-4;  
Group II, Claim 5; Group IV, Claim 6 and Group V, Claim 7.

Applicant hereby elects the subject matter of Group I, Claims 1-2 for prosecution in this application. This election is made without traverse, and it is understood that Applicants' rights to the filing of a divisional application directed to the non-elected subject matter under 35 U.S.C. §120 and 35 U.S.C. §121 are retained.

Response to Restriction Requirement  
Serial No. 10/626,675  
Attorney Docket No. 030901

If this paper is not timely filed, Applicant respectfully petitions for an appropriate extension of time. The fees for such an extension or any other fees that may be due with respect to this paper may be charged to Deposit Account No. 50-2866.

Respectfully submitted,  
**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**



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